

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 242603US2SRD		SERIAL NO. <u>10/65797</u> New Application	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Tadashi SAKAI, et al.			
				FILING DATE Herewith		GROUP 2879	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
<i>JN</i>	AA	6,469,425 B1	10/22/02	Tadashi SAKAI, et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
					YES	NO	
<i>JN</i>	AO	4-274156	09/30/92	Japan			X
	AP	8-236083	09/13/96	Japan			X
	AQ	2002-117771	04/19/02	Japan			X
	AR	2002-298777	10/11/02	Japan			X
	AS	2003-132850	05/09/03	Japan			X
	AT						
	AU						
AV							
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
<i>JN</i>	AW	M. STAMMLER, et al., "FIELD EMISSION MEASUREMENTS WITH MICROMETRE RESOLUTION ON CARBON NANOSTRUCTURES", Diamond and Related Materials, Vol 8 (1999), pgs. 792 - 797. <i>no month</i>					
	AX	Ken OKANO, et al., "LOW-THRESHOLD COLD CATHODES MADE OF NITROGEN-DOPED CHEMICAL-VAPOUR-DEPOSITED DIAMOND", Nature, Vol 381, May 9, 1996, pgs. 140 - 141.					
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner <i>Joseph W. Allen</i>					Date Considered <i>9/27/05</i>		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							